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<tr>
<td>Citation</td>
<td>APPLIED PHYSICS LETTERS (2003), 83(6): 1252-1254</td>
</tr>
<tr>
<td>Issue Date</td>
<td>2003-08-11</td>
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<tr>
<td>URL</td>
<td><a href="http://hdl.handle.net/2433/39657">http://hdl.handle.net/2433/39657</a></td>
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<tr>
<td>Type</td>
<td>Journal Article</td>
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<td>Textversion</td>
<td>publisher</td>
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Switching effect in Cu:TCNQ charge transfer-complex thin films by vacuum codeposition

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(Received 21 April 2003; accepted 14 June 2003)

We demonstrate the operation of an organic switching device using a uniform poly-crystalline Cu:7,7,8,8-Tetracyanoquinodimethane (TCNQ) charge transfer (CT)-complex thin film that is prepared by vacuum vapor codeposition. Characteristic CT-absorption at \(\lambda=600–1200\) nm was observed in the complex film in the UV-visible spectrum and the cyano stretching peak in the IR spectrum shifted to a higher (more than 29 cm\(^{-1}\)) wave number than that of a pristine TCNQ film, suggesting the formation of a CT-complex in the evaporated thin film. Reproducible electrical switching characteristics were observed in the indium tin oxide/Al/(Al\(_2\)O\(_3\))/Cu:TCNQ/Al structure. The device exhibited a clear threshold from low impedance to high impedance at an applied voltage of 10.0±2.0 V and a reverse phenomenon at a negative bias of \(-9.5±2.0\) V. In this study, we demonstrate that a thin Al\(_2\)O\(_3\) layer between the aluminum (Al) anode and Cu:TCNQ layers creates reproducible switching. © 2003 American Institute of Physics. [DOI: 10.1063/1.1600848]

There has been a growing interest in organic electronic devices such as organic light emitting diodes (OLEDs), organic solar cells, organic transistors, and organic switching devices due to the unique electrical and optical properties of organic materials. Recently OLEDs, in particular, have demonstrated significant improvements that have provided highly efficient full-color-display applications. The introduction of thin film transistors (TFTs) is indispensable and high performance organic TFTs have been anticipated for the active matrix driving of OLED displays. In this letter, we focus on a switching phenomenon using a Cu:7,7,8,8-Tetracyanoquinodimethane (TCNQ) charge transfer (CT) complex, which will be useful for organic TFT applications.

Observation of switching phenomena by a Cu:TCNQ CT complex was first reported by Potember et al.\(^4\)–\(^7\) Cu:TCNQ CT-complex films with a grain size of a few micrometers were formed with a solution growth method on a precleaned Cu substrate that was dipped into a solution of degassed acetonitrile (1:1) saturated with TCNQ.\(^3\) Cu:TCNQ films that were \(\sim 10\) \(\mu\)m thick were formed with this method having a poly-crystalline morphology on a Cu substrate and their switching characteristics were first reported with a sandwiched structure of Cu/Cu:TCNQ/Al. However, most devices have a serious problem with homogeneity in the Cu:TCNQ films, leading to a lack of reproducibility in device characteristics. To solve these problems, we fabricated a Cu:TCNQ switching device by vacuum codeposition which allows precise control of Cu and TCNQ contents. In this letter, we report on the reproducible switching characteristics of a Cu:TCNQ codeposited film.

Organic and metal layers were deposited by high-vacuum (1×10\(^{-3}\) Pa) thermal evaporation onto a clean glass substrate pre-coated with an indium tin oxide (ITO) layer (300 nm thick) with a sheet resistance of \(\sim 20\) \(\Omega\)\(\square\). The substrate was degreased with solvents and cleaned in a UV-ozone chamber (Nippon Laser & Electronics Lab., NL-UV253). First, a 20-nm-thick Al layer was thermally deposited on an ITO coated glass substrate and successively transferred into an UV-ozone chamber (12 min, O\(_2\) 1 atm) to form a thin Al\(_2\)O\(_3\) on an Al layer. We found that this procedure to form the thin Al\(_2\)O\(_3\) layer was crucial to obtain reproducible switching characteristics. Next, a 100-nm-thick Cu:TCNQ layer was deposited via thermal codeposition onto the Al\(_2\)O\(_3\)/Al/ITO layer. Finally, a shadow mask with 1 mm diameter openings was used to define the cathode consisting of a 100-nm-thick Al layer, and then the ITO/Al\(_2\)O\(_3\)/Cu:TCNQ/Al device structure was completed. Here, we stress that when we fabricate the devices without breaking vacuum, it was very hard to obtain reproducible switching effect, suggesting formation of a thin Al\(_2\)O\(_3\) layer is responsible for the switching effect. We fabricated an ITO/Al\(_2\)O\(_3\)/Cu:TCNQ/Al device in a similar manner where a thin Al\(_2\)O\(_3\) layer was directly deposited on an ITO substrate by rf sputtering (100 W, \(\sim 2.4\times10^{-1}\) Pa). In these devices, various deposition ratios of Cu:TCNQ, namely, 0:1 (0 atm/mol %), 1:2 (33 atm/mol %), 1:1 (50 atm/mol %), 3:2 (60 atm/mol %), 2:1 (75 atm/mol %) and 3:1 (90 atm/mol %).
FIG. 1. AFM photomicrographs of Cu:TCNQ layers (100 nm) on aluminum (Al) layer with Cu:TCNQ ratios of (a) 1:1, (c) 0:1, and (d) 1:2. Deposited aluminum layer on indium tin oxide layer (b) is also shown for reference.

layer, resulted in a uniform dense poly-crystalline Cu:TCNQ layer. At Cu:TCNQ deposition ratios of 0:1 and 1:2, however, large uneven poly-crystalline textures with a characteristic grain size of ~2 μm were observed, resulting in failure to deposit a uniform metallic cathode electrode. Consequently, we employed a Cu:TCNQ ratio of 1:1 to fabricate the devices.

The absorption spectrum of Cu:TCNQ codeposited films confirms the formation of a CT complex. Figure 2 summarizes the absorption spectra for pristine TCNQ and Cu:TCNQ (1:2, 1:1, 3:2, 2:1, and 4:1) deposited films. A characteristic CT band was observed at 600–1200 nm, while additional vibration at 2129 cm⁻² was also observed in addition to absorption at 2200 cm⁻².


FIG. 3. J–V characteristics of an ITO (300 nm)/Al (20 nm)/(Al₂O₃)/Cu:TCNQ (1:1, 100 nm)/Al (100 nm) device. (Inset) J–V characteristics of an ITO (300 nm)/Cu:TCNQ (1:1, 100 nm)/Al (100 nm) device.
that charge transfer between Cu and TCNQ is also responsible for switching.

To understand the switching mechanisms, we investigated the switching characteristics depending on thickness of the Cu:TCNQ layer and the anode electrodes. Here, we fixed Cu:TCNQ ratio at 1:1 because it had the best switching characteristics. Interestingly, the switching characteristics were almost independent of the Cu:TCNQ thickness (Fig. 5), suggesting that switching is basically an interfacial phenomenon between the electrode and the Cu:TCNQ layer. The anode materials are also crucial in switching. Here, instead of an Al anode, we employed a device structure of ITO/Al$_2$O$_3$/Cu:TCNQ(1:1)/Al where the Al$_2$O$_3$ layer was formed by rf sputtering to confirm its effect. This was because we found that it was necessary to form a thin Al$_2$O$_3$ layer through UV-ozone treatment to obtain reproducible switching characteristics. At Al$_2$O$_3$ thicknesses of 0, 1.0, 5.0, 7.5, 8.8, and 10.0 nm, we observed switching effects with 1.0, 5.0, 7.5, 8.8, and 10.0-nm-thick Al$_2$O$_3$ layers, and a maximum ON/OFF ratio of $\sim 10^4$ with the 7.5-nm-thick Al$_2$O$_3$ layer. We did not observe any switching effects without an Al$_2$O$_3$ layer. Thus, these results indicate that a thin Al$_2$O$_3$ layer on an Al layer is responsible for the switching effect. Due to the large dielectric constant of the Al$_2$O$_3$ layer ($\sim 10$), a high built-in field is formed between the Al/Al$_2$O$_3$ and Cu:TCNQ layer which controls partial charge transfer ($\rho$) between Cu (donor$^+\rho$) and TCNQ (acceptor$^-\rho$). It is often observed that neutral TCNQ molecules provide a mixed valence state with existing TCNQ radical anions in TCNQ columns and mixed valence. TCNQ complexes are more conductive than charge transfer complexes with complete charge transfer. Thus, the external field would convert a significant amount of charge transfer Cu:TCNQ to neutral TCNQ with the application of a forward bias of 10.0 ± 2.0 V and then charge carriers would be subjected to tunneling injection through the thin Al$_2$O$_3$ layer into the Cu:TCNQ layer. However, the reverse switching phenomenon from neutral TCNQ into charge transfer Cu:TCNQ would occur with the application of a reverse bias of $\sim 9.5$ ± 2.0 V. Further researches into understanding the switching mechanism are currently in progress.

In summary, we demonstrated that it was possible to form uniform Cu:TCNQ CT-complex thin films by vacuum codeposition. A device with an ITO/Al/Cu:TCNQ/Al configuration with Cu:TCNQ (1:1) thin film demonstrated reproducible switching characteristics with a large ON/OFF ratio of $\sim 10^4$. We demonstrated that the interface of the Al anode and Cu:TCNQ layers is mainly responsible for high electric field due to the presence of a thin Al$_2$O$_3$ layer, leading to electrical switching. Both the formations of uniform Cu:TCNQ and the thin Al$_2$O$_3$ layers contribute to occurrence of the switching effect.

This work was supported by Integrated Industry Academia Partnership (IIAP) projects from Kyoto University International Innovation Center and the Grant-in-Aid for Scientific Research of the Ministry of Education, Science and Sports in Japan for financial support of this research.